



130.00/122

Patent

Attorney's Docket No. 018414-060

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jang F. CHEN

Application No.: 08/149,122

Filed: November 3, 1993

For: METHOD FOR IMPROVED
LITHOGRAPHIC PATTERNING IN A
SEMICONDUCTOR FABRICATION
PROCESS

Group Art Unit: 1503

Examiner: T. Mosley

16/ Petition
(1.312(b))

PETITION UNDER 37 C.F.R. §1.312(b)

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Applicant hereby petitions for entry of the accompanying Amendment Pursuant To
37 C.F.R. §1.312(b).

This Amendment is directed solely to the correction of typographical errors in the
claims, and does not affect their scope as allowed. These errors were only discovered
after the Issue Fee was paid, when the file was being reviewed in connection with the
preparation of a response in the corresponding PCT application.

Entry of the Amendment is submitted to be proper, and is therefore requested.
Accompanying this Petition is a check for the required fee under 37 C.F.R. §1.17(i).

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS

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By: _____

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Date: May 16, 1994